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SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/589,390	08/15/2006	438	2892	BJS-1035-650
RULE				
APPLICANTS Shigeki Imai, Nara-shi, JAPAN; Kazuhiko Inoguchi, Nara-shi, JAPAN; Hikaru Kobayashi, Kyoto-shi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP05/02352 02/16/2005				
** FOREIGN APPLICATIONS ***** JAPAN 2004-038888 02/16/2004 JAPAN 2004-093703 03/26/2004 JAPAN 2004-093695 03/26/2004				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/09/2007				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/PHUC T DANG/</u> Examiner's Signature	<input checked="" type="checkbox"/> Met after Allowance PD Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 26	TOTAL CLAIMS 34
INDEPENDENT CLAIMS 4				
ADDRESS NIXON & VANDERHYE, PC 901 NORTH GLEBE ROAD, 11TH FLOOR ARLINGTON, VA 22203 UNITED STATES				
TITLE THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE				
FILING FEE RECEIVED 3440	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	